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Attorney Docket No.: F071

EXPEDITE - RESPONSE AFTER FINAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPL. NO: 10/055,320

ART UNIT: 2825

APPLICANTS: Neil J. Bassom et al.

EXAMINER: Renzo Rocchegiani

FILING DATE: January 23, 2002

TITLE: Fabrication of High Resistivity Structures Using Focused Ion Beams

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir or Madam:

Applicants respond as follows to the Final Office Action of June 3, 2004.

Remarks/Arguments begin on page 2 of this paper.

CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office

On September 3, 2004

By: Margarita Marquez-Escalona
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